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10575675 - GAU: 2874

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| Application Number | 10575675 |
| Filing Date | 2007-03-16 |
| First Named Inventor | KHRUSHCHEV |
| Art Unit | 2874 |
| Examiner Name | Quyen P. LEUNG |
| Attorney Docket Number | 8655.001 |

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|---|--|--------------------------|
| 1 | "Terahertz polariton propagation in patterned materials". Nature Materials, Vol. 1 Nr. 2, pages 95-98, October 2002. Stoyanov, N.S. | <input type="checkbox"/> |
| 2 | "Properties of waveguides manufactured with fs-laser pulses in transparent materials"; (CLEO 2001). Technical Digest, Postconference Edition: Baltimore MD : May 6-11, Trends in Optics and Photonics, Vol. 56, page 491; 2001-05-06. | <input type="checkbox"/> |
| | Will, M. | |
| 3 | "Holographic encoding of permanent gratings embedded in diamond by two beam interference of a single femtosecond near-infrared laser pulse"; Japanese Journal of Applied Physics; Publication Office, Japanese Journal of Applied Physics, Tokyo, JP., Vol. 39, Nr. 0A, Part 2, pages L707-709, 2000-09-01, Kawamura, K. | <input type="checkbox"/> |

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